



INTERNATIONAL  
GEMOLOGICAL  
INSTITUTE

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LABORATORY GROWN DIAMOND REPORT

September 18, 2025

IGI Report Number

LG734513680

Description

LABORATORY GROWN DIAMOND

Shape and Cutting Style

ROUND BRILLIANT

Measurements

8.52 - 8.57 X 5.43 MM

GRADING RESULTS

Carat Weight

2.50 CARATS

Color Grade

E

Clarity Grade

VS 1

Cut Grade

EXCELLENT

ADDITIONAL GRADING INFORMATION

Polish

EXCELLENT

Symmetry

EXCELLENT

Fluorescence

NONE

Inscription(s)

 LG734513680

Comments: This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process.  
Type IIa

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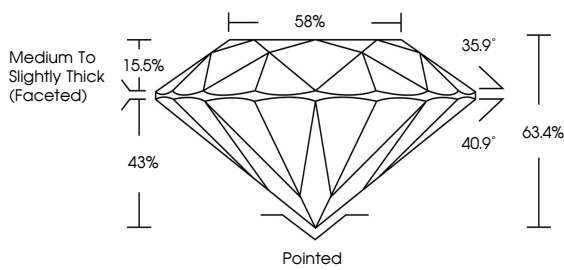
NONE

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PROPORTIONS



Medium To Slightly Thick (Faceted)

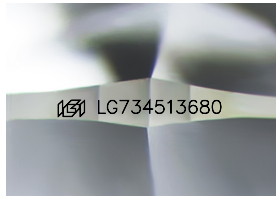
58%

35.9°

40.9°

63.4%

Pointed



Sample Image Used

COLOR

D E F G H I J Faint Very Light Light

CLARITY

IF VS 1-2 VS 1-2 SI 1-2 I 1-3

Internally Flawless Very Very Slightly Included Very Slightly Included Slightly Included Included



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